



P/1250-260

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Tatsufumi KUSUDA et al.  
Serial No.: 10/661,240  
Filed: September 11, 2003

New York, New York  
Date: December 12, 2003  
Group Art Unit: ---  
Examiner: ---

For: PHOTIRRADIATION THERMAL PROCESSING APPARATUS AND THERMAL  
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Alexandria, VA 22313-1450

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Max Moskowitz

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Name of applicant, assignee or  
Registered Representative

Signature  
December 12, 2003

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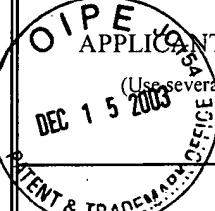
Date of Signature

Respectfully submitted,

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Enclosures

		Application 10/661,240		OFGS File No. P/1250-260		
		Applicant Tatsufumi KUSUDA et al.				
		Filing Date September 11, 2003		Group Art Unit ---		
U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-5,837,058	11-1998	Chen et al. (corresponds to JP 10-074705)	118	728	
	US-4,571,486	02-1986	Arai et al. (corresponds to JP 59-169125)	219	254	
	US-4,649,261	03-1987	Sheets (corresponds to JP 60-258928)	219	390	
	US-6,026,589	02-2000	Yao et al. (corresponds to JP2002-502117)	34	78	
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes
	2000-355766	12-2000	Japan			<input checked="" type="checkbox"/> X
	63-166219	07-1988	Japan			<input checked="" type="checkbox"/> X
	2001-237195	08-2001	Japan			<input checked="" type="checkbox"/> X
	57-162340	10-1982	Japan			<input checked="" type="checkbox"/> X
	10-074705	03-1998	Japan			<input checked="" type="checkbox"/> X
	59-169125	09-1984	Japan			<input checked="" type="checkbox"/> X
	60-258928	12-1985	Japan			<input checked="" type="checkbox"/> X
	2002-502117	01-2002	Japan			<input checked="" type="checkbox"/> X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						